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648.41969CX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: SAITO et al

Serial No.: 10/658,393

Filed: September 10, 2003

For: Method For Manufacturing Semiconductor Device

Art Unit: 2823

Examiner: F. Toledo

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.97 & 1.98Mail Stop: DD
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 5, 2004

Sir:

In the matter of the above-identified application, applicants are submitting herewith copies of the documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.

This information disclosure statement is being submitted before the mailing date of either a final action or a notice of allowance and is accompanied by the following certification specified in 37 CFR 1.97(e).

On information and belief, I hereby certify that each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

To the extent the documents listed on the attached form equivalent to Form PTO-

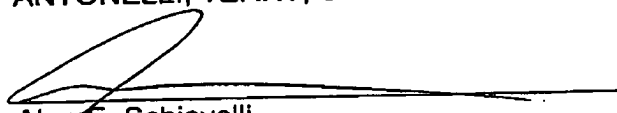
1449 are not in the English language, the requirement of 37 CFR 1.98(a)(3) for a concise explanation of the relevance is satisfied by English language abstracts of the cited documents.

It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case: 648.41969CX1), and please credit any excess fees to such deposit account.

Respectfully submitted,

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